

**RESPONSE AFTER FINAL
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 2221

Myounggoo LEE et al.

Art Unit: 1795

Application No.: 10/658,460

Examiner: Rodney Glenn McDONALD

Filed: September 10, 2003

Attorney Docket No.: 029567-00004

For: BIAS SPUTTERING FILM FORMING PROCESS AND BIAS
SPUTTERING FILM FORMING APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 16, 2008

Sir:

In reply to the February 4, 2008, Office Action, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, begin on page 2;
and

Remarks begin on page 4.